



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Chen, et al.

Serial No.: 09/748,256

Group Art Unit: 2811

Filed: December 27, 2000

Examiner: Ori Nadav

For: METHOD FOR FABRICATING COMPLEMENTARY METAL OXIDE
SEMICONDUCTOR (CMOS) DEVICES ON A MIXED BULK AND SILICON-ON-
INSULATOR (SOI) SUBSTRATE

Honorable Commissioner of Patents
Alexandria, VA 22313-1450
BOX AF

THIRD AMENDMENT UNDER 37 C.F.R. § 1.116

Sir:

Applicant notes that this Amendment is filed concurrently with Appellant's Resubmission of Appeal Brief, and is substantially identical to the Amendment filed herein on January 21, 2004 and the Second Amendment filed on April 19, 2004.

Applicant respectfully submits that the claim amendments included herein clearly do not raise new issues and serve to clarify the issues on appeal. Therefore, this Amendment should be entered.

In response to the Final Office Action dated November 19, 2003, please amend the above-identified application as follows: